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Tech ID: 25353




### ADDITIONAL TECHNOLOGIES BY THESE INVENTORS

- Approaching Schottky-Mott Limit in Van Der Waals Metal Semiconductor Contacts
- Ultrafine Nanowires As Highly Efficient Electrocatalysts
- Chemical Vapor Deposition Growth of the Large Single Crystalline Domains of Monolayer and Bilayer
- Double-Negative-Index Ceramic Aerogels For Thermal Superinsulation
- Single-Atom Tailoring of Platinum Nanocatalysts for High-Performance Multifunctional Electrocatalysis
- Vertical Heterostructures for Transistors, Photodetectors, and Photovoltaic Devices
- Palladium Alloy Hydride Nano Materials
- High Performance Thin Films from Solution Processible Two-Dimensional Nanoplates



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